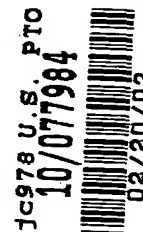


Docket No.: 50094-096

PATENT



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Hong-Da LIU

Serial No.:

Group Art Unit:

Filed: February 20, 2002

Examiner:

For: METHOD FOR THE MANUFACTURE OF A LIQUID CRYSTAL DISPLAY

#4  
15 APR 02  
R. Talbot

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.


The references were cited by or submitted to the U.S. Patent and Trademark Office in parent application Serial No. 09/298,947, filed April 26, 1999, which is relied upon for an earlier filing date under 35 USC 120.

Serial No.:

Thus, copies of these references are not attached. 37 CFR 1.98(d).

Respectfully submitted,


MCDERMOTT, WILL & EMERY

A handwritten signature in black ink, appearing to read "S. Becker", written over the printed name.

Stephen A. Becker  
Registration No. 26,527

600 13<sup>th</sup> Street, N.W.  
Washington, DC 20005-3096  
(202) 756-8000 SAB:prp  
**Date: February 20, 2002**  
Facsimile: (202) 756-8087

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>50094-096</b>		SERIAL NO.	
				APPLICANT <b>Hong-Da LIU</b>			
				FILING DATE <b>February 20, 2002</b>		GROUP	

1c978 U.S. PTO  
 10/07/984  


02/20/02

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						Yes	No

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EXAMINER	DATE CONSIDERED